



# CERTIFICATE OF ACCREDITATION

## The ANSI National Accreditation Board

Hereby attests that

### American Lab LLC

85 Saratoga Avenue, #130  
Santa Clara, CA 95051

Fulfills the requirements of

### ISO/IEC 17025:2017

and national standard

### ANSI/NCSL Z540-1-1994 (R2002)

In the field of

### CALIBRATION

This certificate is valid only when accompanied by a current scope of accreditation document.  
The current scope of accreditation can be verified at [www.anab.org](http://www.anab.org).

A handwritten signature in black ink, appearing to be 'J. Stine', is positioned above a horizontal line.

Jason Stine, Vice President  
Expiry Date: 27 July 2026  
Certificate Number: AC-1468



This laboratory is accredited in accordance with the recognized International Standard ISO/IEC 17025:2017.  
This accreditation demonstrates technical competence for a defined scope and the operation of a laboratory  
quality management system (refer to joint ISO-ILAC-IAF Communiqué dated April 2017).



**SCOPE OF ACCREDITATION TO ISO/IEC 17025:2017**

**AND**

**ANSI/NCSL Z540-1-1994 (R2002)**

**American Lab LLC**  
 85 Saratoga Avenue, #130  
 Santa Clara, CA 95051  
 Ken Silva 408-997-8911

**CALIBRATION**

ISO/IEC 17025 Accreditation Granted: **27 July 2024**

Certificate Number: **AC-1468**

Certificate Expiry Date: **27 July 2026**

**Electrical – DC/Low Frequency**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
DC Voltage – Measure <sup>1</sup>	Up to 100 mV (0.1 to 3) V (3 to 30) V (30 to 300) V	0.34 % of reading + 6.3 μV 0.034 % of reading + 65 μV 0.034 % of reading + 0.66 mV 0.081 % of reading + 58 mV	Comparison to Fluke 753 Documenting Process Calibrator
AC Voltage – Measure <sup>1</sup>	(40 to 500) Hz Up to 3 V (3 to 30) V (30 to 300) V	1.1 % of reading + 2.5 mV 1.1 % of reading + 25 mV 1.2 % of reading + 0.24 V	Comparison to Fluke 753 Documenting Process Calibrator
DC Current – Measure <sup>1</sup>	Up to 30 mA (30 to 100) mA	0.016 % of reading + 6.6 μA 0.017 % of reading + 25 μA	Comparison to Fluke 753 Documenting Process Calibrator
DC Resistance – Measure <sup>1</sup>	Up to 10 Ω (10 to 100) Ω (0.1 to 1) kΩ (1 to 10) kΩ	0.081 % of reading + 58 mΩ 0.081 % of reading + 58 mΩ 0.081 % of reading + 5.8 Ω 0.17 % of reading + 12 Ω	Comparison to Fluke 753 Documenting Process Calibrator
DC Voltage – Source <sup>1</sup>	Up to 100 mV (0.1 to 1) V (1 to 15) V	0.017 % of reading + 5.9 μV 0.017 % of reading + 58 μV 0.017 % of reading + 0.58 mV	Comparison to Fluke 753 Documenting Process Calibrator

### Electrical – DC/Low Frequency

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Current – Source <sup>1</sup>	(0.1 to 22) mA	0.022 % of reading + 3.7 $\mu$ A	Comparison to Fluke 753 Documenting Process Calibrator
DC Resistance – Source <sup>1</sup>	Up to 10 $\Omega$ (10 to 100) $\Omega$ (0.1 to 1) k $\Omega$ (1 to 10) k $\Omega$	0.017 % of reading + 12 m $\Omega$ 0.017 % of reading + 12 m $\Omega$ 0.034 % of reading + 0.24 m $\Omega$ 0.034 % of reading + 3.5 $\Omega$	Comparison to Fluke 753 Documenting Process Calibrator
Electrical Simulation of Thermocouple Measuring Devices <sup>1</sup> (Source)	Type K (-200 to -100) $^{\circ}$ C (-100 to 400) $^{\circ}$ C (400 to 1 200) $^{\circ}$ C (1 200 to 1 372) $^{\circ}$ C	1.3 $^{\circ}$ C 0.71 $^{\circ}$ C 0.7 $^{\circ}$ C 0.7 $^{\circ}$ C	Comparison to Fluke 753 Documenting Process Calibrator
Thermocouple – Measure <sup>1</sup>	Type K (-200 to -100) $^{\circ}$ C (-100 to 400) $^{\circ}$ C (400 to 1 200) $^{\circ}$ C (1 200 to 1 372) $^{\circ}$ C	1.6 $^{\circ}$ C 0.71 $^{\circ}$ C 1.2 $^{\circ}$ C 1.4 $^{\circ}$ C	Comparison to Fluke 753 Documenting Process Calibrator
Electrical Simulation of RTD Indicating Devices <sup>1</sup> (Source)	Pt 385, 100 $\Omega$ (-200 to 100) $^{\circ}$ C (100 to 800) $^{\circ}$ C	0.12 $^{\circ}$ C 0.029 % of reading + 0.093 $^{\circ}$ C	Comparison to Fluke 753 Documenting Process Calibrator
RTD – Measure <sup>1</sup>	Pt 385, 100 $\Omega$ (-200 to 100) $^{\circ}$ C (100 to 800) $^{\circ}$ C	0.16 $^{\circ}$ C 0.046 % of reading + 0.12 $^{\circ}$ C	Comparison to Fluke 753 Documenting Process Calibrator

### Length – Dimensional Metrology

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Bench Micrometer <sup>2</sup>	Up to 10 in	(65 + 10L) $\mu$ in	Comparison to Gage Blocks
Dial/Digital Calipers <sup>1</sup> (Inside, Outside, Depth)	Up to 24 in	390 $\mu$ in	Comparison to Gage Blocks, Micrometer Standards (1 to 11) in

**Length – Dimensional Metrology**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Height Gages/Height Master <sup>1</sup> (Various Types)	Up to 24 in	(127 + 11L) μin	Comparison to Gage Blocks, Micrometer Standards (1 to 11) in, Surface Plate
Dial/Test Indicators <sup>1</sup>	Up to 4 in	80 μin	Comparison to Gage Blocks
Dial/Digital Micrometers <sup>1,2</sup> (Blade, Depth, Flange, Micrometer Head, Inside, Outside)	Up to 10 in	(65 + 10L) μin	Comparison to Gage Blocks, Micrometer Standards (1 to 11) in
Micrometer Standards <sup>2</sup>	(1 to 10) in	(19 + 15L) μin	Comparison to P & W Supermicrometer®, Gage Blocks
Pitch Diameter/External Threads <sup>1</sup>	Up to 4 in	60 μin	Comparison to P & W Supermicrometer®, Etalon Precision Indicating Micrometer, Thread Wires
Gage Blocks <sup>2</sup>	(0.05 to 1) in (1 to 4) in	(13 + 0.9L) μin (29 + 10L) μin	Comparison to P & W Supermicrometer®, Master Gage Blocks
Surface Plates <sup>1</sup> Local Area Flatness Only (Repeat Readings)	Up to 0.005 in	110 μin	Partial Verification per Internal Calibration Procedure #037 using Repeat-o-Meter

**Mass and Mass Related**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Force Devices <sup>1</sup>	(20 to 7 000) gf	0.04 % of reading + 4.6 mgf	Comparison to NIST Class F Weights
Force – Measure <sup>1</sup> (Tension and Compression)	Up to 440 lbf	1 % of reading + 0.2 lbf	Comparison to Digital Force Gage
Torque Tools <sup>1</sup>	(5 to 50) lbf·in	6 % of reading + 0.11 lbf·in	Comparison to CDI Torque Tester

**Mass and Mass Related**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Scales and Balances <sup>1,3</sup>	Up to 2 000 g	0.2 % of reading + 0.6 g	NIST Class F weights and internal procedure #045 utilized for the calibration of the weighing system.

**Time and Frequency**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Frequency – Measure	Up to 30 V rms (1 to 110) Hz (110 to 1 100) Hz (1.1 to 11 kHz) (11 to 50) kHz	58 mHz 0.58 Hz 5.8 Hz 58 Hz	Comparison to Fluke 753 Documenting Process Calibrator
Frequency – Source	Up to 30 V p-p 100 mHz to 10.99 Hz (11 to 110) Hz (110 to 1 100) Hz (1.1 to 22) kHz (22 to 500) kHz	13 mHz 0.12 Hz 0.12 Hz 2.4 Hz 8.2 Hz	Comparison to Fluke 753 Documenting Process Calibrator

Calibration and Measurement Capability (CMC) is expressed in terms of the measurement parameter, measurement range, expanded uncertainty of measurement and reference standard, method, and/or equipment. The expanded uncertainty of measurement is expressed as the standard uncertainty of the measurement multiplied by a coverage factor of 2 ( $k=2$ ), corresponding to a confidence level of approximately 95%.

Notes:

1. On-site calibration service is available for this parameter, since on-site conditions are typically more variable than those in the laboratory, larger measurement uncertainties are expected on-site than what is reported on the accredited scope.
2.  $L$  = length in inches.
3. The CMC for Scales and Balances is highly dependent upon the resolution of the device under test (DUT). The CMC expressed here does not contain does not contain the resolution of the DUT. The resolution will be included in the measurement uncertainty at the time of calibration.
4. Unless otherwise specified in the far-right column, the calibration procedure being used was internally written by the laboratory.



Jason Stine, Vice President